





Save Time

Save Expense Improve Yields

Semiconductor fabs and OEMs worldwide value the accuracy, precision and versatility of the WaferSense AVS – The most efficient and effective wireless measurement device for vibration.



WaferSense®

Auto Vibration System (AVS)

Metrology Sensors

Speed monitoring 3-axis acceleration and vibration, enabling yield improvements.

Records vibration data for easy comparison between past and present, as well as one tool to another, to reduce particles, maintenance time and cycle time.



Speed Equipment Qualification Lower Equipment Expenses

With wireless measurements.

- Collect and display acceleration data wirelessly using the AVS and CyberSpectrum™ software for real-time equipment diagnostics.
- See the effects of adjustments in real time. speeding equipment alignment and setup.

Shorten Maintenance Cycles

Shorten equipment maintenance cycles with wafer-like accelerometer.

- Observe and optimize wafer, cassette, SMIF and FOUP motions using the AVS three-axis
- Detect wafer slides, slips, bumps, scrapes and rough handling in real-time with the vacuum compatible AVS, without opening the tool.
- Optimize motion parameters once the location or absence of wafer damage is identified.

Specifications Form factor Available in 200mm and 300mm AVS200C (200mm) and Part numbers AVS300C (300mm) Software CyberSpectrum Reports accelerations in three directions; x,y and z and RMS Accuracy display allows quick, objective measurements. Resolution: ± 0.01 G Housing material Carbon fiber composite 150 g (200mm), Weight 240 g (300mm) Operating range ± 2G <10⁻⁶ to 760 torr Operating pressure Operating temperature 20 to 70 °C Battery-duration >4 hrs. per charge, 8 hrs. typical Communication Bluetooth, 2.4 GHz Operating system Windows 10 Vibration measurement device, charging clean case, carrying **Product components** suitcase, USB communications link module and application software Factory recalibration Calibration recommended annually

With objective and reproducible data.

- Establish a baseline from a known clean tool, then cycle the AVS through like a dummy wafer to verify that baseline operation continues.
- Receive early warning for impending equipment failures and optimize your preventative maintenance plans.

Optimize Productivity

Optimize equipment productivity and yield by maximizing acceleration and minimizing

Optimized motion profiles and trajectories minimize cycle times and smooth, vibration free handling minimizes particle adders.

For more information. speak with your Nordson representative or contact your Nordson regional office

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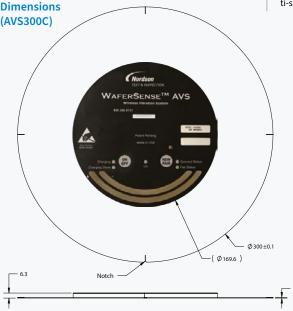
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Real-time data.

CyberSpectrum™ **Software**

Displays real-time visual feedback. Digital readout allows more precise adjustment.

Review functionality integrated; replays log file data for review and analysis.

